## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Noriaki Yokoi

Attorney Docket No.: NMCI P041

Application No.: To Be Assigned

Examiner: To Be Assigned

Filed: July 29, 2003

Group: To Be Assigned

Title: POLISHING SLURRY

**CERTIFICATE OF EXPRESS MAILING** 

I hereby certify that this paper and the documents and/or fees referred to as attached therein are being deposited with the United States Postal Service on July 29, 2003, in an envelope as "Express Mail Post Office to Addressee" service under 37 CFR §1.10, Mailing Label Number EV334022082US, addressed to the Commissioner for Patents, Alexandria, Virginia 22313-1450.

Jeffrey Ng

INFORMATION DISCLOSURE STATEMENT 37 CFR §§1.56 AND 1.97(b)

Commissioner for Patents Washington, DC 20231

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application. These references were cited in the Examination Report by a foreign patent office in the corresponding PCT application on which priority for the instant application is based.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits.

Respectfully submitted,

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Form 1449 (Modified)	Atty Docket No.	Application No.:
	NMCI P041	To Be Assigned
Information Disclosure	Applicant:	
Statement By Applicant	Noriaki Yokoi	
	Filing Date	Group
(Use Several Sheets if Necessary)	July 29, 2003	To Be Assigned

## **U.S. Patent Documents**

Examiner						Sub-	Filing Date
Initial	No.	Patent No.	Date	Patentee	Class	class	Date
	A						
	В						
	C						
	D						
	E					***	
	F						

Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Translation	
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
	G	1,104,778A2	06/06/01	EP			X	1
	Н	2001-152133	06/05/01	JP				X
	I	2001-300843	10/30/01	JP		İ	İ	X
	J	2002-30271	01/31/02	JP			-	X
	K	58-31241	03/01/83	JP		1	1	X
	L	2002-80825	03/22/02	JP				X
	M	2002-97456	04/02/02	JP			<b>†</b>	X

## **Other Documents**

Examiner		
Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	N	Matsui, et al. US Patent Application Publication 2002/0006728A1 (Publication date: 01/17/02)
1		
Examiner		Date Considered
<b>D</b>	T '.' 1	

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.